



DOCKET NO: 284901US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
HACHISHIRO IIZUKA : EXAMINER: KEATH T. CHEN
SERIAL NO: 10/565,676 :
FILED: JANUARY 24, 2006 : GROUP ART UNIT: 1709
FOR: GAS REACTION SYSTEM AND :
SEMICONDUCTOR PROCESSING
APPARATUS

AMENDMENT UNDER 37 C.F.R. § 1.111

COMMISSIONER FOR PATENTS
Alexandria, VA 22313

Sir:

In response to the Office Action of June 5, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 6 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

Remarks begin on page 7 of this paper.